

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Fujio ITO et al.

Appln. No.:

Filed: Herewith

For: A SEMICONDUCTOR DEVICE AND A METHOD OF MANUFACTURING
THE SAME

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.56, and without any
assertion as to materiality or prior art effect, the
documents listed on the attached Form PTO-1449 are hereby
cited.

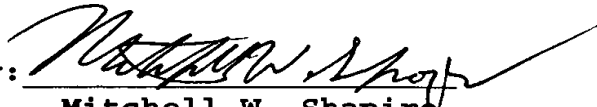
The documents on the attached List were cited in the
specification, on page 2, and their relevance is indicated
therein.

Respectfully submitted,

MWS:lat

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By:


Mitchell W. Shapiro
Reg. No. 31,568

December 9, 2003

FORM PTO-1449		Atty. Docket No. XA-9996	Appln. No.
LIST OF DOCUMENTS CITED BY APPLICANT		Applicant Fujio ITO et al.	
		Filing Date HEREWITH	Group

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AJ	2001-189410	7/10/01	Japan			Abstract
	AK	3072291	5/26/00	Japan			Abstract
	AL						
	AM						
	AN						
	AO						

OTHER (including author, title, date, pertinent pages, etc.)

	AP	
	AQ	
	AR	

Examiner	Date Considered
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XAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.